

Attorney Docket No. 032566-066 Patent 032566-066

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of  
Soojin Oh et al.

Application No.: 10/615,842

Filing Date: July 10, 2003

Title: DEPOSITION METHOD FOR NANOSTRUCTURE MATERIALS

Group Art Unit: 1753

Examiner: Brian L. Mutschler

Confirmation No.: 9995

THIRD  
INFORMATION DISCLOSURE STATEMENT  
TRANSMITTAL LETTER

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Enclosed is a THIRD Information Disclosure Statement and accompanying form PTO-1449 for the above-identified patent application.

- ☒ No additional fee for submission of an IDS is required.
- ☐ The fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e) is also enclosed.
- ☐ A statement under 37 C.F.R. § 1.97(e), and the fee of \$180.00 (1806) as set forth in 37 C.F.R. § 1.17(p) are also enclosed.
- ☐ Charge \_\_\_\_\_ to Deposit Account No. 02-4800 for the fee due.
- ☐ A check in the amount of \_\_\_\_\_ is enclosed for the fee due.
- ☐ Charge \_\_\_\_\_ to credit card. Form PTO-2038 is attached.

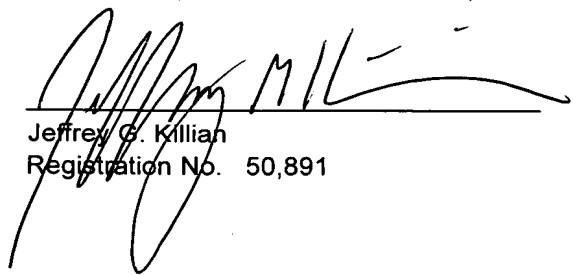
The Director is hereby authorized to charge any appropriate fees under 37 C.F.R. §§ 1.16, 1.17 and 1.21 that may be required by this paper, and to credit any overpayment, to Deposit Account No. 02-4800. This paper is submitted in duplicate.

Respectfully submitted,

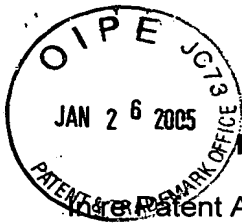
BURNS, DOANE, SWECKER & MATHIS, L.L.P.

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By

  
Jeffrey G. Killian  
Registration No. 50,891

Date: January 26, 2005



**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

## ~~Inter~~ Patent Application of

Soojin Oh et al.

**Application No.: 10/615,842**

**Filed: July 10, 2003**

For: **DEPOSITION METHOD FOR  
NANOSTRUCTURE MATERIALS**

Group Art Unit: 1753

**Examiner: Brian L. Mutschler**

**Confirmation No.: 9995**

### THIRD INFORMATION DISCLOSURE STATEMENT

**Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450**

**Sir:**

In accordance with the duty of disclosure as set forth in 37 C.F.R. § 1.56, the accompanying information is being submitted in accordance with 37 C.F.R. §§ 1.97 and 1.98.

Pursuant to 37 C.F.R. § 1.98, a copy of the document cited is enclosed.

The documents are being submitted within three (3) months of the filing or entry of the national stage of this application or before the first Office Action on the merits, whichever is later. Since these documents are being filed within the time period set forth in 37 C.F.R. § 1.97(b), no fee or statement is required.

To assist the Examiner, the document is listed on the attached form PTO-1449. It is respectfully requested that an Examiner initialed copy of this form be returned to the undersigned.

Respectfully submitted,

**BURNS, DOANE, SWECKER & MATHIS, L.L.P.**

Date January 26, 2005

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Jeffrey G. Killian  
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# **THIRD INFORMATION DISCLOSURE STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet 1

of

1

**Complete if Known**

Application Number	10/615,842
Filing Date	July 10, 2003
First Named Inventor	Soojin Oh et al.
Examiner Name	Brian L. Mutschler
Attorney Docket Number	032566-066

JAN 26 2005

**U.S. PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Name of Patentee or Applicant of Cited Document	Issue/Publication Date (MM-DD-YYYY)

**FOREIGN PATENT DOCUMENTS**

Examiner Initials	Document Number	Kind Code (if known)	Country	Date of Publication (MM-DD-YYYY)	STATUS						
					Translation	Partial Translation	Eng. Lang. Summary	Search Report	IPER	Abstract	Cited In Spec

**NON-PATENT LITERATURE DOCUMENTS**

Examiner Initials	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
	B. GAO et al., "Fabrication and Electron Field Emission Properties of Carbon Nanotube Films by Electrophoretic Deposition", <i>Advanced Materials</i> , Vol. 13, Issue 23, pp. 1770-1773, published online November 23, 2001.

Examiner Signature	Date Considered
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with M.P.E.P. § 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.